Se	earc	h N	ote	S



Application/Co	Application/Control No.	
10/611,953		
Examiner		

Erick Rekstad

Applicant(s)/Pate Reexamination	Applicant(s)/Patent under Reexamination		
KIM, MOON-CH	EOL		
Art Unit			
2621			

	CHED	
Subclass	Date	Examiner
700 155	5/4/2007	ER
170	5/4/2007	ER
	3	•
		<u> </u>
	700 155	700 155 5/4/2007

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
	1		
	<u>. </u>		

(INCLUDING SEA	DATE	EXMR
	DATE	EXIVIR
keyword search IEEE search PLUS search	5/4/2007	ER
·		
•		
•		